

EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|--------|---|-------------------------------------|------------------|---------|---------------------|
| L1 | 8061 | (257/750,758,759,762,774).CCLS. | US-PGPUB; USPAT; EPO; DERWENT | OR | OFF | 2008/01/04 14:18 |
| L2 | 2435 | L1 and (si silicon) adj substrate | US-PGPUB; USPAT; EPO; DERWENT | OR | OFF | 2008/01/04 14:19 |
| L3 | 1858 | L2 and (dielectric passivation polymer) | US-PGPUB; USPAT; EPO; DERWENT | OR | OFF | 2008/01/04 14:20 |
| L4 | 278 | L3 and ((si silicon) adj substrate) near5 (contact pad terminal) | US-PGPUB; USPAT; EPO; DERWENT | OR | ON | 2008/01/04 14:21 |
| L5 | 84 | L4 and @ad<"19981221" | US-PGPUB; USPAT; EPO; DERWENT | OR | ON | 2008/01/04 14:27 |
| L6 | 1 | L5 and "polymer layer" | US-PGPUB; USPAT; EPO; DERWENT | OR | ON | 2008/01/04 14:28 |
| L7 | 336310 | (metalization interconnection "metal trace") | US-PGPUB; USPAT; EPO; DERWENT | OR | ON | 2008/01/04 14:30 |
| L8 | 30212 | L7 and (si silicon) adj substrate | US-PGPUB; USPAT; EPO; DERWENT | OR | OFF | 2008/01/04 14:30 |
| L9 | 26855 | L8 and (dielectric passivation insulation insulating polymer interlayer) | US-PGPUB; USPAT; EPO; DERWENT | OR | ON | 2008/01/04 14:31 |
| L10 | 3049 | L9 and ((si silicon) adj substrate) near5 (contact pad terminal) | US-PGPUB; USPAT; EPO; DERWENT | OR | ON | 2008/01/04 14:31 |
| L13 | 537 | L10 and ("polymer layer" polymer) | US-PGPUB; USPAT; EPO; DERWENT | OR | ON | 2008/01/04 14:34 |
| L14 | 150 | L13 and @ad<"19981221" | US-PGPUB; USPAT; EPO; DERWENT | OR | ON | 2008/01/04 14:34 |

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